



PATENT
Docket No. 20067/OPP031479US

**IN THE UNITED STATES PATENT
AND TRADEMARK OFFICE**

Applicant(s): Tae-Hee Park

Serial No.: 10/749,650

Filed: December 30, 2003


For: "Methods of Forming Metal Lines in
Semiconductor Devices"

Group Art Unit: Unknown

Examiner: Unknown

) I hereby certify that this paper is
) being deposited with the United
) States Postal Service with
) sufficient postage as first class
) mail in an envelope addressed to:
) Commissioner for Patents, P.O.
) Box 1450, Alexandria, VA 22313-
) 1450 on this date:

) **April 30, 2004**

) 
) Mark C. Zimmerman
) Registration No. 44,006
) Attorney for Applicant(s)

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The patents listed on the enclosed PTO Form-1449 are submitted pursuant to 37

CFR §§ 1.56, 1.97, and 1.98. Copies of the patents are enclosed.

TIME OF FILING

This information disclosure statement is being filed, to the best of the undersigned's knowledge, before the mailing date of a first Office action on the merits. In accordance with 37 CFR §1.97(b), no certification or fee is required.

METHOD OF PAYMENT

No fee is required.

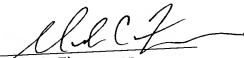
The Commissioner is authorized to charge any fee deficiency required by this paper, or credit any overpayment, to Deposit Account No. 50-2455. A copy of this paper is enclosed.

Correspondence Address:

Respectfully submitted,

GROSSMAN & FLIGHT, LLC.
20 N. Wacker Drive
Suite 4220
Chicago, Illinois 60606
(312) 580-1020

By:


Mark C. Zimmerman
Registration No.: 44,006

April 30, 2004



Form PTO-1449 (Modified)	U.S. Department of Commerce Patent and Trademark Office	Atty. Docket No.	Serial No.
		20067/OPP031479US	10/749,650
		Applicant	
		Tae-Hee Park	
INFORMATION DISCLOSURE STATEMENT <i>(Use several sheets if necessary)</i>		Filing Date	Group Art Unit
		December 30, 2004	Unknown

U.S. PATENT DOCUMENTS							
*EXAMINER INITIALS		DOCUMENT NUMBER	ISSUE DATE	INVENTOR(S)	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	A01	5,886,410	05-23-1999	Chien Chang, et al.	257	759	
	A02	6,238,582	05-29-2001	Kurt Williams, et al.	216	22	

EXAMINER	DATE CONSIDERED
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance <u>and</u> not considered. Include copy of this form with next communication to applicant.	